tronic, optoelectronic, photovoltaic, thermoelectric, and superconducting uses.

# **BASIC CONCEPTS OF ELECTRICAL CONDUCTION**

Electrical conduction occurs through transport of electric charge in response to an applied electric field. Electric charge is carried by electrons, electron holes, and ions. Electrical conductivity  $\sigma$  and its reciprocal, electrical resistivity,  $\rho = 1/\sigma$ , are physical properties of the material. While the range of values are somewhat arbitrary, electrical conductivity is very low in insulators,  $\sigma$  < 10<sup>-15</sup> S/cm ( $\rho > 10^{21} \mu \Omega \cdot$ cm), intermediate in semiconductors,  $\sigma = 10^{-5}$  S/m to  $10^3$  S/cm ( $\rho = 10^3$ to  $10^{11}~\mu\Omega\cdot$ cm), very high in conductors,  $\sigma = 10^4$  S/m to  $10^6$ S/cm ( $\rho = 1$  to  $10^2 \mu \Omega \cdot$ cm), and infinite in superconductors.

Electrical conductivity,  $\sigma$ , is defined as the product of the number of charge carriers, *n*, the charge, *e*, and the mobility of the charge carriers,  $\mu$ :

$$
\sigma = n \cdot e \cdot \mu \tag{1}
$$

For electronic conductors the electron charge,  $e = 1.6 \times 10^{-19}$ C, is constant and independent of temperature. The mobility,  $\mu$ , usually decreases with increasing temperature due to collisions between the moving electrons and phonons (i.e., lattice vibrations). The number of charge carriers, *n*, remains constant for metallic conductors with increasing temperature, but increases exponentially for semiconductors and insulators. Thus at very high temperatures some insulators become semiconducting, while at low temperatures some semiconductors become insulators.

## **Electronic Band Model**

Electronic conduction in a solid can be described in terms of the electronic band model. Quantum mechanics designates for each electron location probabilities as well as allowed energy levels, also called electronic orbitals. Thus, an isolated atom forms a potential well with discrete electron energy levels. If two such atomic wells are brought into proximity, then from the Pauli exclusion principle, which forbids any two electrons from occupying the same energy level (neglecting electron spin), the isolated discrete energy levels split into two sets (bonding and antibonding levels). When a large number, *N*, of such wells are brought into proximity, then the original discrete energy levels broaden into quasi-continuous bands, each of which comprises *N* energy levels. The gaps between the bands may be preserved but are smaller than between the original discrete levels; for some bands, notably the outer (or valence) band, the gaps may even vanish and the bands overlap. Whether a certain material is a conductor, semiconductor, or insulator may then be described by the electronic band theory.

**CONDUCTING MATERIALS If a band is only partially filled, thermal excitation is suf**ficient to let the electrons easily move within the band contin-This article will present briefly principles of electrical conduc- uum. On the other hand, if the band is completely filled, no tion followed by a discussion of electron- and ion-conducting electron movement is possible. Since energy levels are promaterials. Apart from well-known metals and alloys for elec- gressively filled from the lowest to the highest, all the inner trical wires, cables, and contacts, several new classes of syn- bands are completely filled and conduction occurs only in the thetic organic, inorganic, and composite conductors (1,2) have outer or valence bands. In metallic conductors, the valence become available. The particular attraction of these materials bands are only partially filled with electrons. The high number of mobile electrons, typically on the order of  $10^{22}/\text{cm}^3$ , ac-

is that one can tailor their electronic properties for microelec-

In network solids such as diamond or silicon, valence The quantum theory of superconductivity describes a lowbands are completely filled consistent with strong directional temperature condensed state of electrons in which they intercovalent bonds. In addition, there is an appreciable energy act, through the atomic lattice, to form temporary pairs (Coogap to the next empty (conduction) band. Electrons cannot per pairs). An electron traveling through the crystal exerts an move freely within the bands, and these materials do not ef- attractive force on the ions, pulling them together as it passes ficiently conduct electricity. In diamond, for instance, the en- between them. While the metal ions remain close together, ergy gap between the valence band and the conduction band they create a region of abnormally concentrated positive is 6 eV (1 eV =  $1.6 \times 10^{-19}$  J), making it an excellent insulator. In semiconductors, such as silicon, the band gap between between the electrons is very large, about 10,000 times the the valence band and the empty conduction band is smaller; distance between neighboring ions. The interaction between typically in the range of 0.5 eV to 3.0 eV. At room tempera- the electrons is therefore very weak and can be disrupted by ture, the thermal energy,  $k_B T = -0.03$  eV, is small compared to the energy gap. With increasing temperature, more and only occurs at low temperatures. Cooper pairs, unlike the more electrons have sufficient thermal energy to be promoted electrons (which are fermions), are bosons, which can occupy into the empty conduction band. The vacated positions in the all the same low-energy state. Because of their low-energy valence band are regarded as positive holes, which contribute state, Cooper pairs are not readily scattered and flow unimto the electrical current by moving in the opposite direction peded. Unfortunately, this theory does not allow the predicof the negatively charged electrons. Pure silicon, for example, tion of the new high-temperature superconductor materials. has about  $10^{10}$  electron and hole carriers per cm<sup>3</sup> at ambient temperature. **CONDUCTIVE MATERIALS** Exertion of pressure onto solids narrows the valence and

conductance band gaps and ultimately, with high enough **Metals and Alloys** pressure, all materials should show a metallic transition. The diatomic I<sub>2</sub> molecules become metallic at  $\sim$ 210 kbar, and even **Pure Metals.** The charge transport in pure metals is caused the noble gas xenon turns into a metallic phase at 1.3 Mbar. by the drift of free electrons (or "electron gas"). (In some met-In metals themselves, pressure tends to decrease the ampli- als like beryllium and zinc, the movement of charge is considtudes of lattice vibrations and therefore causes a slight de- ered to be due to electron holes.) Free electrons have comparcrease in resistivity. Pressure effects on synthetic conductors atively high velocities and relatively long mean free paths are more varied and not well investigated. In some cases and until they collide with ions constituting the crystal lattice. at very low temperatures, exertion of high pressure allows This process is called scattering. In a perfect periodic lattice one to achieve superconductive properties. structure, no collisions would occur and the resistivity would

related by the relationship  $k_{th}/k_{el} = LT$ , with the Lorentz to 100  $\mu$ 12 cm at 100m temperties is given in Table 1.

loss due to resistance. The phenomenon of superconductivity mounts/chassis, power line conductors, heat sinks, mechanicame to be known in 1911 by observing a thin column of mer- cal fixtures, etc. Its excellent resistance to corrosion in many cury abruptly losing its resistance when immersed into a liq- environments is due to the protective, highly adherent oxide uid helium bath at 4.2 K. It was later established that super- film that develops in the presence of oxygen. conductivity can exist only below a critical temperature  $T_c$  Copper is the most widely used electrically conducting maand a critical magnetic flux density  $B_c$ . A superconductor, un- terial. Its advantages are high thermal and electrical conduclike a perfect conductor, does not conserve the magnetic field tivity (surpassed only by pure silver) and relatively low cost. flux within it, but rather expels the flux (Meissner effect). Pel- Copper is easily soldered to and has good mechanical characlets of superconducting yttrium barium copper oxide ceramic teristics, including tensile strength, toughness, and ductility. hover above magnets at liquid nitrogen temperature. The ef- Due to its low coefficient of thermal expansion and high ten-

charge to which a second electron can be attracted. Distance thermal vibrations of the ions. This explains why the effect

be zero (not to be confused with superconductivity). Mean free **Thermal Conductivity paths of the electrons are limited by (1) ionic vibrations due** Thermal conductivity in solids is provided by lattice vibra-<br>to thermal energy; (2) the crystal defects, such as vacancies,<br>tions (phonons) as well as the movement of free electrons. In<br>dislocations, grain boundaries, Fre

Most Commonly Used Metal Conductors. Aluminum, a basic<br>integrated circuit metalization element today, is also used for Superconductors carry electrical current without any energy the production of lightweight shielding cans, component

## **82 CONDUCTING MATERIALS**





sile strength, copper finds widespread use in overhead trans- *Conductivity of Dilute Alloys.* The Bloch model suggests that mission lines. Copper is fairly corrosion resistant and tar- the electrical resistivity is mainly a consequence of distur-

graphite is slightly less than that than that of metals and lattice, giving rise to additional impurity scattering. The re-<br>their alloys. Pure carbon, in contrast, is a semiconductor with sistivities of an alloy would then a negative temperature coefficient of resistance. In electrical that of its pure metal solvent at the same temperature. This engineering, carbon (graphite) elements are extensively used is described quantitatively by the Matthiesen rule: as (1) brushes for electrical machines; (2) electrodes for electric-arc furnaces, electrolytic baths, and welding; (3) nonwire  $\rho_a(T) = \rho_p(T) + \rho(c)$ resistors; (4) battery cell elements; and (5) microphone and other components of telecommunication equipment. Carbon where  $\rho_a(T)$  and  $\rho_p(T)$  are the temperature variations of the and graphite are used also as sliding electrical contacts be- resistivities of the dilute alloy and the host and  $\rho(c)$  is the cause of their ability to withstand temperatures up to  $3000^{\circ}$ C, concentration-dependent resistivity of the foreign atoms.

low density, ability not to weld to metals, self-lubricating properties, and inexpensive production. Graphite fibers have a very high thermal conductivity, far greater than that of copper, and are being used for lightweight, heat-management applications.

Silver is a very soft metal and not normally used industrially in its pure state, but is alloyed with a hardener, usually copper. Silver is malleable and ductile and does not oxidize in air at room temperature. Silver does, however, absorb considerable amounts of oxygen at elevated temperature and is tarnished by sulfur compounds. Its major industrial applications are as electric contacts on relays and in instruments rated for small currents. Silver migrates under electric potential and, if used in microelectronics circuits, needs to be contained by diffusion barriers such as tungsten, palladium, or nickel.

Pure gold has unsurpassed resistance to oxidation and sulfidation. However, susceptibility to erosion limits its use in electrical contacts to currents below 0.5 A. Gold sometimes forms a carbonaceous deposit in the presence of volatile organic compounds, increasing contact resistance. The low hardness of gold can be increased by alloying with copper, silver, palladium, or platinum.

The refractive platinum metals (Pt, Pd, Rh, Ir, Os, Ru) are highly resistive to corrosive environments. Stable thermoelectric behavior, high resistance to spark erosion, tarnish resistance, and broad ranges of electrical resistivities and temperature coefficients of electrical resistance make platinum metals useful for a number of electrical applications, such as thermocouples or contacts for telephone relays. Platinum and palladium are most commonly used. Low electrical and thermal conductivities and high cost generally exclude them, however, from use for currents above 5 A.

Tungsten is stronger than any common metal at temperatures over 2000°C and has the highest melting point of all metals,  $3380^{\circ}$ C. The electrical resistivity is about three times as high as copper but better than that of platinum or nickel. The high-temperature stability of tungsten is exploited in lamp filaments and electronic filaments, in which it serves as a light- or electron-emitting cathode material. Tungsten is used in electrical engineering as a wear-resistant material for contacts and parts of vacuum devices. Molybdenum is not as widely used as tungsten as it oxidizes more readily and erodes faster on arcing. Molybdenum contacts are advantageous where mass is important. It is widely used for mercury switches because it is wetted, but not attacked by mercury.

### **Metal Alloys**

nishes only superficially in air.<br>
Graphite is a crystalline, allotropic form of carbon of very a dilute alloy the solute impurity atoms, typically less than Graphite is a crystalline, allotropic form of carbon of very a dilute alloy the solute impurity atoms, typically less than high melting point  $(3700^{\circ}C)$ . The electrical conductivity of 5% dissolve randomly and substitu 5%, dissolve randomly and substitutionally into the solvent sistivities of an alloy would then be expected to be larger than

$$
\rho_a(T) = \rho_p(T) + \rho(c)
$$

Material	Thermal Conductivity $(W/m \cdot K)$	Resistivity $(\mu \Omega \cdot \text{cm})$ at 20°C	Liquidus/Solidus (°C)
48Sn52In	34	14.7	118
42Sn58Bi		39	138
62Sn36Pb2Ag	49	14.8	179
63Sn37Pb	51	15	183
96.5Sn3.5Ag	33	10.8	221

**Table 2. Properties of Some Eutectic Solder Alloys**

*Conductivity of Concentrated Alloys.* For concentrated alloys, complete solubility between the constituent atoms rarely occurs, and most binary alloy systems are character-<br>
ized by the presence of miscibility gaps at room temperature.<br>
The alloy is then a mixture of two disordered solid solutions.<br>
Depending on the equilibirum phase

Qualitatively, completely soluble binary solid solutions ity and comparatively low values of temperature coefficient of<br>show a bell-shaped resistance curve, whereas completely in-<br>resistance (TCR). Pure metals, in contrast miscible binary composites show a depressed line between the very high TCRs of several thousand ppm. Additional require-<br>resistivities of the pure elements Resistivity changes with ments for resistive alloys are high mecha

is also used for third rails.<br>
Copper alloys containing tin, cadmium, beryllium, and cer-<br>
tain other metals are called bronzes. They have a lower elec-<br>
trical conductivity (20% to 85%) than pure copper but are<br>
more res more resistant to corrosion and wear. The greater tensile heat-resistant, conducting materials that are used for heating<br>correctly allows agree of these allows to be used as trailey elements in heaters and furnaces (Table strength allows some of these alloys to be used as trolley wires.

Soldering and brazing are simple joining processes in which metals are wetted and joined together by a dissimilar metal of a lower melting temperature. Most conventional solders (6) are used below a temperature of 300°C. Solders are typically alloys of tin with other metals, such as lead, silver, copper, antimony, cadmium, indium, and bismuth. Properties of some very common eutectic solders, such as 63Sn37Pb, are given in Table 2. The driving force for joining is the formation of intermetallic tin compounds with metals such Cu, Ni, Au, Pd, and Ag.

Brazes or hard solders are used to join two or more pieces of metals above a temperature of 400°C. Brazes refer to copper-zinc, copper-silver, copper-aluminum, aluminum-zinc, and aluminum-silicon alloys. Similar to solders, joint formation is often driven by an intermetallic reaction of a braze component with the metals to be joined. One such example is brazing solder, which has 51% copper and 49% zinc content.

Material	Composition	Resistivity $(\mu \Omega \cdot \text{cm})$ at $20^{\circ}$ C	<b>TCR</b> $(\Omega/\Omega \cdot {}^{\circ}C)$ in $ppm)$	Thermoelectric Potential $(\mu V/C)$
Manganins	Cu13Mn	48	15	1
	Cu <sub>13</sub> M <sub>n4</sub> N <sub>i</sub>	48	15	$-1$
	Cu10Mn4Ni	38	10	$-1.5$
Constantans	Cu43Ni	49	20	$-43$
	Cu45Ni	50	40	$-42$
NiCrAl alloys	Ni20Cr3Al2Cu (Fe, Mn)	133.0	20	$-0.1$
	Ni20Cr3Al5Mn	135.5	20	$-0.1$

**Table 3. Properties of Some Resistance Alloys**

ture, and the composition, an alloy may exist as a mixture of the metals with a disordered structure. The disordered structure, many phases, each with its own distinct resistivity  $(3-5)$ .<br>Consisting and therefore to high

resistivities of the pure elements. Resistivity changes with ments for resistive alloys are high mechanical strength, high expecially when multiphase systems can be very compicated, melting point, corrosion resistance at





volatile, strongly adherent surface oxide film (e.g., NiO, valuable for temperature measurements. A thermocouple con- $Fe<sub>2</sub>O<sub>3</sub>$ ,  $Cr<sub>2</sub>O<sub>3</sub>$ ) that excludes access of further air/oxygen to the sists of wires of two dissimilar materials, a positive and a alloy. However, sulfur is destructive to Ni–Cr and Ni–Cr–Fe negative component, which are joined at their ends to form a

are compounds of two or more metals that have a distinct versely, if a current flows through those junctions, a reversstructure in which the metallic constituents are usually or- ible change in heat content (i.e., heating and cooling) can be dered on two or more sublattices, each with its own distinct perceived (Peltier effect). For thermocouples, typical positive population. Deviations from the precise stoichiometry are, components are Fe, Ni–Cr, and Cu, with constantan as the however, common and can be exploited to tailor lattice con- negative component. Materials with large Seebeck and Peltier stants. Due to their highly ordered structure, intermetallic effects may be used for thermoelectric cooling. Thermoelectric compounds have a high melting point and are very hard couples based on Be–Te–Se couples give cooling of at least (brittle).  $-50^{\circ}\text{C}$  and are used in small, silent refrigerant devices.

recovery and gilding of less noble metals for more than 3000 are temporary junctions between two conductors. Materials years. SiC and  $M_0Si_2$  are well-known resistance heating ma- for these applications require a low-contact electrical resisterials (Table 4). Today, apart from many structural and tance, resistance to high-contact force and mechanical wear, high-temperature applications, intermetallic compounds have high-voltage breakdown strength, and the ability to withfound various advanced electrical uses (7,8). Intermetallic su- stand arcing. Due to corrosion, contact surfaces usually acperconductors, such as  $Nb_3Sn$ ,  $Nb_3Al$ , or  $YPd_2B_2C$  (9), are quire a film of oxides, which has low conductivity and reduces investigated for high-magnetic-field generators, high-speed the effectiveness of electrical contacts. Acceptable contact maanalog devices, and power conservation. Compound semi- terials include copper, molybdenum, nickel palladium, platiconductor materials such as GaAs and InP exhibit very high num silver, and tungsten. For high-voltage (100,000 V) and electron mobilities, leading to applications in very high-speed high-amperage (10,000 A) applications, alloys of precious and transistors. IMCs such as HgCdTe, CuInSe<sub>2</sub>, CuGaSe<sub>2</sub>, and refractory metals are used. Typical alloys are Ag(40– CuGaSe<sub>2</sub> are useful for optoelectronic applications such as  $50$ )Mo( $50-60$ ), Ag( $40-75$ )W( $25-60$ ), and Cu( $55-70$ )W( $30-45$ ). optical switches, solar cells, photodetectors, light-emitting Sliding contacts in variable resistors and rheostats are made diodes, and lasers. Intermetallic compounds such as PbTe, of bronze-nickel or platinum alloys. Bi2Te3, and transition metal silicides, such as the nonstoichio- *Metals and Alloys for Thin Film Applications.* Thin film conmetric  $MnSi<sub>1.72</sub>$ , show a high thermoelectic effect (TE) and are ductive and resistive materials (10) are used for the fabricaused in TE thermocouples, TE generators, TE radiation detec- tion of microelectronic devices. Materials are deposited by tors, and TE coolers. physical (PVD) or chemical (CVD) vapor deposition methods.

fusion barriers for thin film semiconductor devices. Diffusion copper. NiCr and TaN are the most common resistor materiof one species into another causes rapid degradation of electri- als. Diffusion barriers are needed to prevent the degradation cal contacts. Intermetallic diffusion barriers are also used to of metal/metal interfaces. Nickel is an effective barrier mateprevent degradation of fibers in metal matrix composite fabri- rial for Au/NiCr interfaces, preventing Cr from diffusing into cation, to improve wettability in soldered or brazed joints, and Au. Palladium, platinum, molybdenum, and tungsten serve to prevent interdiffusion of the components of a brazing alloy as barrier materials and as adhesion layers. with the substrate material. Diffusion barrier materials are Metal oxide films from tin (usually tin–antimony alloys),

(160C), Pb50Sn18Cd (145C), Bi26Pb20Cd (103C), and methods, a complement to the thin film CVD methods. Bi25Pb13Sn10Cd (72C). The fusing current is given by the *Metals for Cryogenic Hyperconductors.* Cryogenic hyperconrelation  $I_{\text{fuse}} = AD^{n}$ , where A and n are empirical constants for

tance of these alloys is due to the formation of a dense, non- *Metals and Alloys for Thermocouples.* Thermocouples are inalloys, usually more so with higher nickel content. closed loop. If the two junctions are kept at differential tem-*Intermetallic Compounds.* Intermetallic compounds (IMCs) peratures, an electrical current flows (Seebeck effect). Con-

The intermetallic compound Au–Hg has been used for gold *Metals and Alloys for Electrical Contacts.* Electrical contacts

Intermetallic compounds have proven very effective as dif- Typical conductor materials are gold, aluminum, silver, and

chosen to limit reaction with either the substrate or the over- indium (usually indium–tin alloys), tin-cadmium alloys, and layer. Intermetallic compound examples for diffusion barriers zinc have been reported to exhibit high electrical conductivity include Al<sub>3</sub>Ti, Al<sub>3</sub>Hf, Co<sub>2</sub>Si, and NiSi. In IC fabrication, sili- combined with the great optical transparency. The oxides are cides such as WSi<sub>2</sub>, MoSi<sub>2</sub>, and TaSi<sub>2</sub>, which can be easily very robust and environmentally stable. Indium tin oxide etched, are used for gate metallization. TiN is an effective (ITO), which reaches resistivities down to  $4 \times 10^2 \mu\Omega \cdot cm$ , is barrier between Al and the Si substrate. employed to form transparent electrical contacts for liquid crystal displays.

Special Electric and Electronic Applications for Metals<br>and Alloys and Alloys<br>and Alloys are employed to fabricate pure metal conductors and films. These compounds are<br>cate pure metal conductors and films. These compounds *Metals and Alloys for Fuses.* Fusible metals and alloys are thermolabile and lose their organic constituent upon heating. used for circuit interruption when current density rises be- Precious metal conductors can be obtained often by processing yond the rated values. At the fusing current, the fuse mate- in air, while base metals have to be handled under inert or rial melts from joulean heating, causing an open circuit and reducing atmospheres to avoid formation of metal oxides. preventing possible damage of the circuit. Typical low-melt- Metal–organic compounds can be applied in form of inks, ing-point fuse materials are Pb (327°C), Cd (321°C), Bi sprayed on as organic solvent solutions, or deposited by  $(271^{\circ}\text{C})$ , Sn  $(232^{\circ}\text{C})$ , In  $(156^{\circ}\text{C})$ , Bi80Sn  $(200^{\circ}\text{C})$ , Bi50Pb metal-organic chemical vapor deposition  $(MOCVD)$   $(11,12)$ 

ductors are metals whose resistivity is rather low (but still a given metal and *D* is the wire diameter. higher than superconductors) at the cryogenic temperatures

**Table 5. Superconducting Metals and Alloys**

Type I	$T_c$ (K)	Type II	$T_c$ (K)	Type III	$T_c$ (K)
Al	1.18	$Pb-In$	7.0	$La1.85Sr0.5CuO4$	40
In	3.41	Ph–Bi	8.3	$YBa2Cu3O7$	95
Sn	3.72	Nb–Ti	9.5	$Bi_2Sr_2CaCu_2O_8$	85
Pb	7.20	$Nb-N$	16.0	$Bi_2Sr_2Ca_2Cu_3O_{10}$	110
Nb	9.25	PbMo <sub>6</sub> S <sub>8</sub>	15.0	$Tl_2Ba_2CaCu_2O_8$	108
		V.Ga	15.0	$Tl_2Ba_2Ca_2Cu_3O_{10}$	125
		$\rm V_{3}Si$	16.0		
		Nb <sub>3</sub> Sn	18.0		
		Nb <sub>3</sub> Ge	23.0		

of liquid helium (4.2 K), neon (27.1 K), or nitrogen (77.4 K). ily been used in substrate materials as well as insulation lay-<br>At these temperatures the electrical resistance of the hyper-<br>attificant conductors drops shar

cess. Conduction concepts involve soliton, polaron, and **Nanometals and Semiconductors.** Nanosized metal (Au, Ag, Pd, Pt) and semiconductor (CdSe, InP) clusters smaller than 10 nm and containing a few hundred to a few thousand of atoms exhibit size-dependent electronic properties that drastically differ from the bulk. While initial interest was mainly spurred by catalytic and magnetic recording applications of nanosized transition metal clusters, it became clear that small metal and semiconductor particles may also serve as functional units in innovative nanoelectronic devices for highcapacity computers and optoelectronic switches (13). This requires the assembly of clusters into stable, interconnected, low-dimensional structures, such as quantum wells (2-D),

quantum wires (1-D), and quantum dots (0-D), and has been achieved so far with various degrees of success. Nanoclusters are easily prepared by vapor condensation methods, thermolysis of metalorganic compounds, or reduction of metal salts in solution. Nanosized gold clusters, which have a deep purple color, have long been used as coloring agents for cell organelles.

# **Synthetic Conductors**

**Intrinsically Conducting Polymers.** Polymers find widespread use as structural and functional materials. Among several advantages, they are lightweight and high strength and can be customized. In the electronic industry, polymers have primar-

Superconducting Metals and Alloys. Although superconduce or a stack of molecular poker chips. They are approximate in the matter of an analyon one-dimensional conductors, materials that conduct in one and organic comparin

**Table 6. Resistivity of Some Polymers**

Material	Resistivity $(\mu \Omega \cdot cm)$
Copper	1.67
Polyacetylene	$10 - 10^{3}$
Polyphenylene vinylene, polythiophene, polypyrrole, polyaniline (emeraldine)	$10^3 - 10^4$
Ionically conductive polymers	$10^{7}-10^{14}$
Polystyrene, fluoropolymers	$10^{24}$

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bipolaron electronic states, which ''hop'' along the chain. ''In- combined with Kevlar (DuPont) to produce robust pro-

duced a resistivity of  $10^4 \mu \Omega \cdot \text{cm}$  (10<sup>2</sup> S/cm). Further research However, conductivities indicate thermally activated (semiyielded materials with room temperature resistivity of 10 conducting) behavior.  $\mu\Omega$  cm, while other conducting systems have also produced materials with resistivities of  $10^3 \mu\Omega \cdot$  cm. There is a problem **Conductive Composites** 

with mast of these polymers in that the conductivity belse. Conductor-tasked belsetting, Dielectrica and explores and the conductivity of the conductivity relations of the conductivity relations of the conductivity relati

pounds such as TCNQ-TTF, tetracyano and bisoxalato platinates (Krogman salts), and macrocyclic ligand metal complexes. Conductivities of these compounds are typically in the range of  $10^8$   $\mu\Omega$  cm to  $10^{10}$   $\mu\Omega$  cm. (TMTSF)<sub>2</sub>ClO<sub>4</sub> was the first organic compound found to be superconductive (1.3 K).

[*M*(phtalocyanine)O]*<sup>n</sup>* polymers have been also synthesized, where  $M = Si$ , Ge, Sn converted to covalently linked, partially oxidized chain compounds. These materials have high environmental and thermal stability and are soluble without decomposition in strong acids. The polymers can be

terhopping'' between adjacent chains is also believed to occur. cessable, orientable fibers and when partially oxidized are The initial work on polyacetylene doped with iodine pro- good electrical conductors  $(10^8 \mu \Omega \cdot cm)$  in stacking direction).

Stacked One-Dimensional Conductors. Recently a number of<br>stacked, one-dimensional conductors has been synthesized<br>(17,18). This group comprises organic charge-transfer com-<br>(17,18). This group comprises organic charge-tran

**Table 7. Critical Volume Fraction vs. Size**

Size $(\mu m)$	$V_{\rm c}$
	$-0.10$
5	0.25
12	0.30
15	0.40
35	0.50

loaded with silver, copper, nickel, graphite, or inherently conductive polymers as the conductor phase (21–23). PTF inks are typically applied by silk screening or spray coating and can be processed below  $200^{\circ}$ C. Their main uses are electromagnetic interference (EMI) shielding coatings and specialized electrical interconnection applications in the printed circuit board (PCB) industry, such as conductive adhesives, via fill materials and resistors. Highly loaded silver inks can achieve conductivities of 1/20 that of bulk silver. A major issue with PTF inks, however, is that electrical properties may be compromised by temperature and humidity fluctuations, leading to oxidation of the particle surfaces and deterioration CdO), and an organic vehicle (ethyl cellulose). The thick film of particle-to-particle contacts due to polymer expansion. inks typically require processing temperatures above 850C, High conductor loadings required to achieve acceptable elec- at which the organic binder is burned out and the metal partitrical conductivity can, in addition, lead to mechanical and cles undergo sintering. Thick film conductors contain noble adhesive failures. metals (Cu, Ag, Au, Pd, Pt) or refractory metals (Ni, Mo, W),

sistors and thermistors (temperature-dependent resistors). resistors contain thermally stable precious metal oxides, such Resistive PTF inks are loaded with mixtures of carbon blacks as  $RuO_2$  (RhO<sub>2</sub>, IrO<sub>2</sub>) and Pb/Bi<sub>2</sub>Ru<sub>2</sub>O<sub>7</sub>, as conductive phase. and graphite, which are available with a range of conductivi- Resistivities range from  $10^6 \mu \Omega \cdot cm$  to  $10^{12} \mu \Omega \cdot cm$ . Thermisties. Low-resistance inks are obtained by addition of silver. tors are usually made from doped ceramics such as barium Additives need to be balanced in such a way that the temper- titanate, which has a relatively high resistivity ( $10^8 \mu\Omega$ ) cm ature coefficient of resistance (TCR) is as low as possible  $10^9 \mu\Omega \cdot cm$ ) and thus limits their use. Chromium doped vanahave a very large negative (NTC) or positive (PTC) tempera-  $\mu\Omega$  cm), but properties are harder to control. ture coefficient of resistance. Thermistors are used as current Applications of cermets other than in microelectronics are such as  $V_2O_2$ , TiB<sub>2</sub>, and Ni in polyethlene have shown similar used in low-voltage applications in tropical climates. low room temperature resistivities with large PTCs.

sient-liquid-phase-sinterable (TLPS) (24) conductive compos- acceptance as substitutes for traditional electronic packaging ites were developed to overcome the shortcomings of PTF materials. These materials can be reliably and cost-effectively inks. TLPS pastes typically contain a metal, such as Cu, Ag, fabricated by liquid infiltration of aluminum into a reinforceor Ni, and a solder-type component, such as SnPb or SnBi, ment matrix. They have a low coefficient of thermal expantogether with a permanent polymeric adhesive binder. During sion (CTE), high thermal and electrical ( $\leq 40 \mu\Omega \cdot$ cm) conducheating (typically less than 220°C) the solder component tem- tivity, and low density while providing increased strength porarily melts, wets, diffuses, and reacts with the solid metal (25). The low density makes aluminum matrix composites atcomponent to form a high-melting, intermetallic compound, tractive for weight critical applications, such as in avionics such CuSn<sub>3</sub> or Cu<sub>5</sub>Sn<sub>6</sub>. Eventually a continuous, three-dimen- or in portable electronic equipment (26). Recently, aluminum sional metallic web is formed, which does not remelt at the matrix composites (27) using aluminum nitride (AlN) have process temperature. Polymer-metallic TLPS composites are been shown to have properties equal to or superior to those of analogous to the ceramic-metallic (cermet) inks that have the more commonly used aluminum/silicon carbide (Al/SiC) been used in hybrid circuit manufacturing for many years. composites (Table 8). TLPS composites do provide low bulk resistivity ( $\rho = 25$  $\mu\Omega$  cm), comparable to cermet materials, as well as very good **Intercalated Graphite.** Because of its excellent conductance,

form of thick film inks, which are composed of an active com- halogens, which behave as electron acceptors. ponent  $(<5 \mu m$  fine metal powders, ceramic powders, met-<br>Graphite intercalated with potassium, rubidium, or cesium aloxides), a glassy binder (Pb-borosilicate glass, PbO, CuO, becomes metallic and exhibits superconductivity below 1 K.

**Table 8. Thermal Properties of Aluminum, Al/AlN, and Al/SiC**

Material	Thermal Conductivity $(W/m \cdot ^{\circ}C)$	Mean CTE (ppm/°C) $35-350$ °C	Density $(g/cm^3)$
Aluminum	212	25.2	2.697
Al/SiC $(55.0 \text{ vol\%})$	126	12.0	2.979
Al/AlN $(62.7 \text{ vol\%})$	129	11.1	3.019

Carbon-black-loaded polymer composites have uses as re- achieving conductivities of 1/15 that of bulk silver. Thick film  $\langle 300 \text{ ppm}/^{\circ}$ C. In contrast to resistors, thermistor materials dium sesquioxide,  $(V, Cr)_2O_3$ , has a lower resistivity  $(10^3$ 

limiters by becoming insulators at a certain temperature. copper graphite cermet contacts, which are noted for a mini-Composite polymer-based thermistors have been made to im- mum welding tendency in heavy-current circuit breakers. Beprove ease of processing and to decrease room temperature cause of their excellent resistance toward wear and arc eroresistivity compared to ceramic thermistors. Carbon-black sion, cermets are also used for conductor-included ceramic polyethylene is the most widely used commercial composite contacts. Cadmium oxide–based cermets containing silver, thermistor type with resistivities around 10<sup>6</sup>  $\mu\Omega$  cm. Fillers nickel, or tungsten as the conductive phase are extensively

**Metal Matrix Composites.** Metal matrix composites, in par-**Transient-Liquid-Phase-Sintering Polymer Composites.** Tran- ticular aluminum matrix composites, have gained increased

environment stability and adhesive strength. graphite is considered to be a semimetal. Graphite has a layered structure with a 0.335 nm separation between layers, **Conductor-Loaded Ceramics.** Conductor-loaded ceramics in- which can expand to accommodate larger guest atoms or molclude metals, graphite, and metal oxides as the conductive ecules. In effect, the intercalants form charge transfer comphase. While most ceramic-metallic composites, also known pounds although the exact nature of intercalation reaction is as cermets, are used for high-temperature structural applica- not entirely known. Intercalants may be divided into two tions, a subgroup is also widely used in ceramic thick film groups: (1) alkali metals, which act as electron donors, and hybrid microcircuits. These types of cermets are applied in  $(2)$  proton acids  $(HNO<sub>3</sub>)$ , Lewis acids (metal halides), and

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at 300°C in the presence of graphite. All alkali metal graph- misnomer for  $M_2O-nX_2O_3$ , where *n* is 5 to 11, *M* is a monovaites are extremely reactive with air and water. When interca- lent cation, and *X* is a trivalent cation. Resistivity for the lated with AsF<sub>5</sub>, graphite also becomes metallic, showing a Na<sup>+</sup> ion in Na<sub>2</sub>O–5Al<sub>2</sub>O<sub>3</sub> at 25<sup>o</sup>C is comparable to strong liqconductivity even somewhat higher than copper. Potential ap- uid electrolytes ( $\langle 10^9 \mu \Omega \cdot cm \rangle$ ). plications for intercalated graphite are EMI shielding or wiring for use in power transmission, aircraft electronic systems,<br>or internal carriers in transformers or motors. In the labora-<br>cal conductors are the polymer salt complexes, also termed

Alkali salts of buckminsterfullerene, a soccer ball–shaped much in contrast to this, the conduction mechanism in the  $C_{60}$  allotrope of carbon, have been a recent addition to the polymer-ion-type conductors involves ion

occurs is also called the  $\alpha$ -phase to  $\beta$ -phase transition. This -phase to -phase transition. This **Molecular Scale Electronics** temperature is well above 300 K for typical solid electrolytes such as AgI, LiZr<sub>2</sub>PO<sub>4</sub>, Li<sub>3</sub>N, and Li<sub>3</sub>B<sub>7</sub>O<sub>12</sub>S. Principal charge If the current trend in size reduction in electronic devices is

 $10^{20}/\text{cm}^3$  is useful for fast ion conductors.  $10^{20}/\text{cm}^3$  is useful for fast ion conductors.  $\frac{1}{\text{cm}}$  or related techniques.

Molten sublattice defects correspond to insufficient sites in The ability of biomacromolecules to self-assemble into<br>the sublattice region for the available ions to occupy them. higher-order suppramolecular structures with This results in ionic hopping or free-ion movement from one tionalities has prompted chemists to explore synthetic methavailable site to the other. This process allows all the ions to ods of self-assembly. Molecular self-assembly can be considparticipate in the conduction phenomenon with the result ered as a means of producing nanometer-scale structures in a that the activation energy is rather low. The mobile ions as reproducible manner without recourse to lithography. A varicharge carriers amount to nearly  $10^{23}/\text{cm}^3$ . The material is a liquid-like molten sublattice, often realized via channeled or trapped in molecular cages, interlocked ring molecules, and

such as fuel cells (Mn-doped cobalt chromite, Ni, or Co-zirco- Surface modification of the molecule enables the electron nia cermets), solid-state batteries (AgI, LiI,  $Na<sub>2</sub>O-A<sub>2</sub>O<sub>3</sub>$ ), cou-transfer to be directed to external electrodes. lombmeters (AgBr, RbAg4I5), electrochemical capacitors (AgI, Ion transport through ion channels in membranes is well AgBr,  $RbAg<sub>4I<sub>5</sub></sub>$ ), and oxygen sensors (Ca stabilized zirconia, known and would be another way of molecular scale commu-CSZ).  $\beta$ -Alumina has been pioneered by the Ford Motor com- nication. It could be controlled by applied voltages and chemi-

The bronze red  $C<sub>s</sub>K$  is prepared by evaporation of potassium pany for high-density energy storage systems.  $\beta$ -Alumina is a

or internal carriers in transformers or motors. In the labora-<br>
tory, a composite has been formed by enclosing powdered in-<br>
tercalated graphite into a copper matrix (one third copper)<br>
and swaging it into wires. Other int

the doped polymer conductors manifest as much as seven or-**Solid Electrolytes**<br> **Solid Electrolytes** ders of magnitude higher conductivities. Typical examples for<br> **Solid Electrolytes** of the set of the set of the polymer salt complexes are polyethylene oxide (PEO) and "Fast" lon Conductors. Migration of ions does not occur to polymer salt complexes are polyethylene oxide (PEO) and<br>any appreciable extent in most ionic and covalent solids, such metal salts. Conductivity depends mainly on

carriers are cations and anions, while the contribution of elec- maintained, sometime in the first half of the twenty-first centrons is very small. Conduction in solid electrolytes is sus-<br>tury the molecular scale will be reached (31). Doped polyacet-<br>tained by defects in the crystalline structure.<br> $\frac{1}{2}$ <br> $\frac{1}{2}$ <br> $\frac{1}{2}$ <br> $\frac{1}{2}$ <br> $\frac{1}{2}$ ylene—a quasi-molecular wire—marked the early begin-Point defects allow thermally induced ionic transport nings. Since then the prospects for progress toward molecular through Frenkel (or Schottky) defect pairs. Hence, the num- scale electronics has much improved as scientific developber of defects and the proportionate number of charge carriers ments have provided the means to explore and manipulate are functions of temperature, requiring an activation energy properties of molecular systems at the molecular level using in excess of 1 eV. A defect concentration on the order of scanning tunneling (STM) and atomic force (AFM) microscopy

higher-order supramolecular structures with specific funcety of approaches have been developed that provide molecules layered structures. The rings on linear molecular chains. Highly efficient electron Solid electrolytes are applied in engineering applications transfer can occur in biomolecules such as bacteriorhodopsin.

cals. Simple channels can be, for instance, formed from spe- *duction Conf. NEPCON West,* Des Plaines, IL: Reed Exhibition cialized peptides. Since many ions can go through these ion gates, this would open the possibility of fanouts from one gate 25. A. L. Geiger and M. Jackson, Low expansion metal-matrix composites for electronic packaging, *Proc. 2nd ASM Int. Electron.* to many.

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**CONDUCTING MATERIALS.** See ELECTRONIC COMPO-<br> *Chanised Vener* Deposition for Metalligation Wojphoim: Verlag NENTS.